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CASE PP/1-22826/A/CGC 2139

CERTIFICATE OF MAILING

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Anna R. Maddalena

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF

Group Art Unit: 1751

HUI CHIN ET AL

Examiner:

APPLICATION NO: 10/761,821

FILED: JANUARY 21, 2004

FOR: ANTISTATIC COMPOSITION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 CFR 1.56, Applicants wish to call the Examiner's attention to the references cited on the attached form PTO-1449.

Copies of these references are enclosed herewith.

The Examiner is requested to consider the foregoing information in relation to this application and indicate that each reference was considered by returning a copy of the initialed PTO 1449 form.

Respectfully submitted,

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Encl. References
PTO-1449 Form

Sheet 1 of 1

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) PP/1-22826/A/CGC 2139	Application Number 10/761,821
	Applicant HUI CHIN ET AL	
	Filing Date JANUARY 21, 2004	Group Art Unit 1751

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2000226749	8/00	Japan			✓	
	2000212836	8/00	Japan			✓	
	2000212834	8/00	Japan			✓	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	English language abstract for JP 2000226749 (2000)
	English language abstract for JP 2000212836 (2000)
	English language abstract for JP 2000212834 (2000)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.